

Electronic Acknowledgement Receipt

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International Application Number:	
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Title of Invention:	STRUCTURES AND METHODS FOR MANUFACTURING P-TYPE MOSFET WITHGRADED EMBEDDED SILICON-GERMANIUM SOURCE-DRAIN AND/OR EXTENSION
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Amendment - After Non-Final Rejection	FIS920040116US1_Amendment_01-09-2007.pdf	226618	no	7

Warnings:

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Total Files Size (in bytes):	226618
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